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Oxidized titanium tungsten surface functionalization by silane, phosphonic acid or ortho-dihydroxyaryl based organolayers

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organolayers; functionalization; XPS; ToF-SIMS; nanoelectronics; stability.

ABSTRACT. 200 nm thick films of titanium tungsten (TiW) were cleaned by oxygen plasma and the resulting oxidized surfaces were functionalized by 3-aminopropylphosphonic acid (APPA), 3-ethoxydimethylsilylpropylamine (APDMES) or dopamine (DA) to form three different organolayers. The three resulting organolayers were characterized by X-ray photoelectron spectroscopy (XPS), Time-of-flight secondary ion mass spectrometry (ToF-SIMS) and Fourier transform infrared spectroscopy (FTIR) analysis. Stability of each organolayer was investigated. Our results suggested that the Si-O-Ti or Si-O-W bonds issued from the reactions of APDMES with surface oxidize TiW were rather labile whereas the catechol layer was less labile. The APPA layer was the most stable of all tested surface modifications.

Introduction

Surface chemical functionalization of inorganic materials has been developed for various applications, such as surface patterning fabrication,¹ tissue engineering,² biosensors³ and corrosion inhibition.⁴ Surface chemical functionalization can be achieved either using polymeric material deposition or by the attachment of low molecular weight functional molecules bearing a chemical group that can react with the surface of the materials (substrate-binding head group) to form an organolayer.

The development of new generations of ISFETs based on up-to-date nanoelectronic devices is currently being explored. Industrially produced Fully Depleted Silicon On Insulator (FDSOI) structures are for instance being explored for ultrasensitive detection of chemical species.^{5,6} Such FDSOI structures could also be used as transducers in ultrasensitive BioFETs. BioFETs classically require to elaborate a first organolayer onto the transducer surface, followed by grafting of biomolecular probes. In order to be of interest to nanoelectronic companies, the formation of organolayers needs to be implemented on materials used by this industry. Among

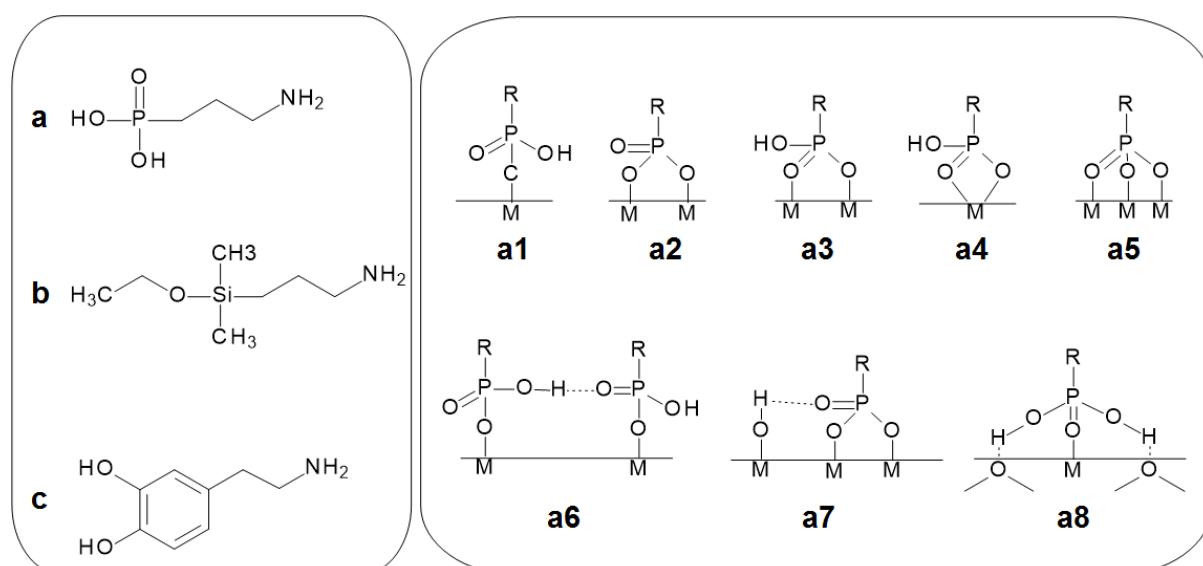
materials classically used for elaborating nanoelectronic devices in the Back end of line (BEOL), gold is considered as a contaminant for electrical contacts and is avoided. TiW is commonly used in nanoelectronic architectures, thanks to its excellent fabrication reproducibility. It is classically used as diffusion barrier and is considered as very stable⁷⁻¹⁵. Specialists of nanoelectronic industry consider TiW oxide surface as particularly stable, from structural and chemical point of views, even on a long term. This type of surface therefore exhibits a strong potential for industrially produced chemical sensors and biosensors based on nanoelectronic transducers. However, despite the fact that the surface modification of titanium oxide has been widely described, and the one of tungsten oxide has been scarcely reported, to the best of our knowledge, surface chemical functionalization of TiW has never been reported.^{16,17}

In this context, this study concerns the formation of organolayers on 200 nm thick TiW films deposited on silicon wafers. Since titanium and tungsten are prone to form oxide layers, we first assessed that a surface oxide layer is indeed present after plasma oxygen cleaning. Next, we compared the formation of organic layers on plasma cleaned TiW using organosilane, phosphonic acid and ortho-dihydroxyaryl compounds. Indeed, these binding head groups have been reported for the formation of organolayers on oxides.¹⁸ Three molecules: 3-aminopropylphosphonic acid (APPA), 3-ethoxydimethylsilylpropylamine (APDMES), dopamine (DA) were used. Nitrogen was used as an elemental reporter (elemental signature of the molecules). The three layers were characterized by X-ray photoelectron spectroscopy (XPS), Time-of-flight secondary ion mass spectrometry (ToF-SIMS) and Fourier transform infrared spectroscopy (FTIR). Finally, their stability in aqueous medium was compared.

Experimental section

Materials

200-nm thick TiW layers was prepared by STMicronics on silicon substrate. Chemicals were commercially available. Reagent or higher grade chemicals were used. Dopamine hydrochloride 97% (DA) and 3-aminopropylphosphonic acid (APPA) 97% were purchased from Sigma-Aldrich. (3-aminopropyl)-dimethylethoxysilane (APDMES) 99.9% was purchased from abcr GmbH. The chemical structures of the three molecules are shown in **Scheme 1**. Dichloromethane (DCM) 99.9% was purchased from Sigma-Aldrich and dried over molecular sieves before use. The deionized water (18.2 M Ω) used for all the experiments was obtained using a VEOLIA purelab water system.



Scheme 1. Chemical structures of (a) APPA, (b) APDMES and (c) DA. Right: examples of possible binding modes of APPA with metal: (a1) monodentate APPA; (a2, a3) bridging bidentate APPA ; (a4) chelating bidentate ; (a5) bridging tridentate ; (a6, a7, a8) additional hydrogen-bonding interactions. (after Brodard-Severac et al.¹⁹).

Surface functionalization

The substrates were cleaned by oxygen plasma treatment (Anatech) at 400 sccm of oxygen, 350 W of forward power (10 W reflected power) for 5 min to remove organic contamination

and to obtain a hydroxyl-terminated surface. Herein TiW functionalized by APPA, APDMES and DA organolayers are named by APPA-TiW, APDMES-TiW and DA-TiW, respectively. Following O₂ plasma treatment, organolayers were formed by following protocols for APPA²⁰ APDMES,²¹ and DA²² previously assessed in the literature:

- APPA-TiW: substrates were immersed in 10 mM APPA aqueous solution for 24 hours. The samples were then washed with ultrapure water for 5 min under sonication rinsed with a stream of ultrapure water and dried with a nitrogen flow.
- APDMES-TiW: substrates were immersed in 25 mL dried DCM containing 10 µL APDMES (3mM) for 48 hours. The samples were then rinsed with fresh DCM for 5 min under ultrasound (Branson, 42 kHz, 100 W) followed by a stream of ultrapure water and dried with a nitrogen flow.
- DA-TiW: substrates were immersed in a 0.5mg/mL degassed DA aqueous solution for 24 hours under nitrogen. The samples were then washed with ultrapure water for 5 min under sonication, rinsed with a stream of ultrapure water and dried with a nitrogen flow.

Organolayers stability study

APPA-TiW, APDMES-TiW, and DA-TiW were immersed in ultrapure water and incubated at 70 °C for 0, 15, 30 or 60 minutes. After removal from the hot water, the samples were rinsed in room temperature ultrapure water and were dried with a nitrogen flow.

Characterization

The crystal structure of the materials was characterized by X-ray diffraction (XRD) using a Rigaku Smartlab diffractometer with a rotating anode (power=9kW). The source CuK radiation was monochromatized by a double Ge (220) crystal to select the CuK α_1 ray ($\lambda = 0.15406\text{nm}$). The detector was a point scintillation counter. X-ray diffraction measurements were performed

with a diffractometer equipped with a rotating anode operating at 9 kW monochromatized with a two reflection Ge (220) crystal which selects the Cu K α 1 radiation (wavelength = 1.5406 Å). The detector was a scintillation counter. The measurements were performed by varying the Bragg angle between $2\theta = 10^\circ$ and $2\theta = 80^\circ$, the step size was set to 0.01° and the scan speed was set to $3^\circ/\text{minute}$.

The surface topography of oxidized TiW was monitored using a SMENA B (NT-MDT) AFM microscope in the tapping modulation (AM) mode with Mikromash XSC11 with Al backside tips (resonance frequency = 80 kHz). The data analysis was performed with Gwyddion Software.

Attenuated total reflectance Fourier transform infrared spectroscopy (ATR-FTIR) was performed using a Thermo Nicolet 6700 spectrometer with MCT detector (Electron Corporation, USA) by a germanium crystal from 800 cm^{-1} to 4000 cm^{-1} . Results were obtained from averages of 256 scans at a resolution of 4 cm^{-1} .

Time-of-flight secondary ion mass spectrometry (ToF-SIMS) measurements were performed using a Physical Electronics TRIFT III instrument (Physical Electronics, Chanhassen, MN) operated with a pulsed Au ion gun (ion current of 2nA) over a $300\text{ }\mu\text{m} \times 300\text{ }\mu\text{m}$ area. The ion dose was kept below the static condition limits. Data were analyzed using WinCadence software. Mass calibration was performed on hydrocarbon secondary ions.

X-ray Photoelectron Spectroscopy (XPS) measurements were performed using a VSW spectrometer equipped with a monochromatized X-ray source (Al K α 1486.6 eV) in which the angle between the incident beam and the detector is the magic angle. Its angular resolution is 3° . Take-off angle was 90° relative to the substrate surface. The energetic resolution was 0.2 eV. The data analysis was performed with CasaXPS software. W4f $_{7/2}$ binding energy was set at 31.6 eV. Full widths at half maximum (FWHM) for the core levels Si2p $_{3/2-1/2}$, P2p $_{3/2-1/2}$ were 1.7eV and 1.9eV, respectively, while FWHMs for the core levels N1s and O1s were 1.7, and

1.4 eV, respectively. These rather large FWHM values were due to slight charging effects, lack of counting as the samples were sensitive to the beam and longer acquisition times would not be relevant. A Shirley background was subtracted on W4f and Ti2p spectra when coming from bulk elements while a linear background was subtracted on all other spectra when coming from surface elements. Peaks were fitted by a Gauss-Lorentz curve independently but with the atomic ratio and distance of spin-orbit doublets respected: 2.1eV for W4f and 6.1eV for Ti2p.

Results and discussion

Characterization of TiW oxidized with O₂ plasma

TiW substrate was studied by XRD, AFM, and XPS after O₂ plasma oxidation. The crystal structure of the materials was characterized by X-ray diffraction (XRD) using a Rigaku Smartlab diffractometer with a rotating anode. The XRD pattern (**Figure 1**) shows a Bragg peak at $2\theta = 39.92^\circ$ in agreement with to the TiW bcc phase.^{5,6,12,15} AFM image showed that the TiW surface morphology exhibits small islands about 100nm wide and 35-40nm high as shown in **Figure 2**. The Root Mean Square (RMS) was found to be around 3.9 ± 0.5 nm.

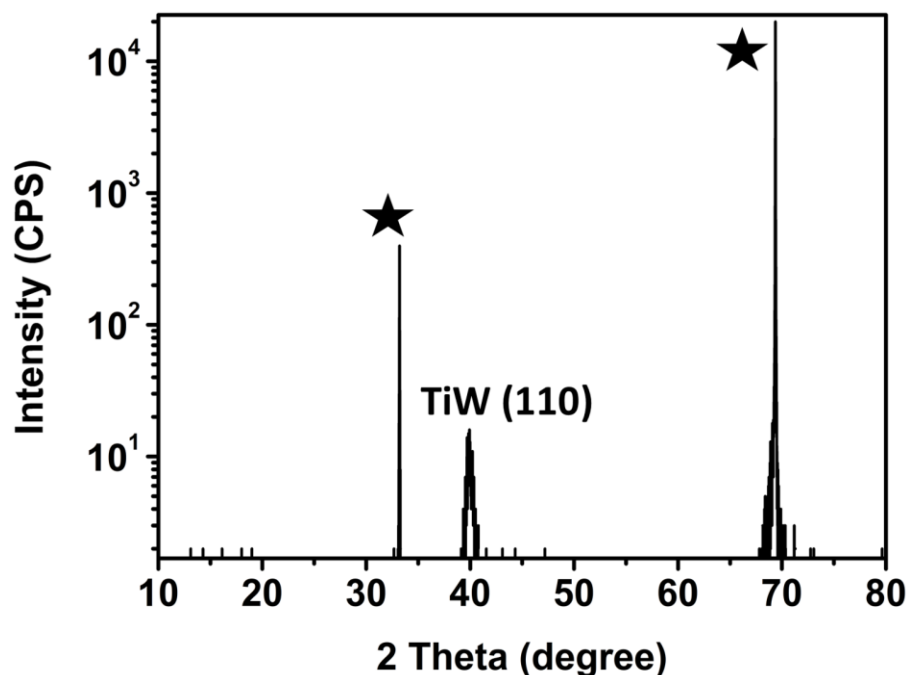


Figure 1. XRD pattern of TiW substrate. Stars correspond to the Silicon substrate.

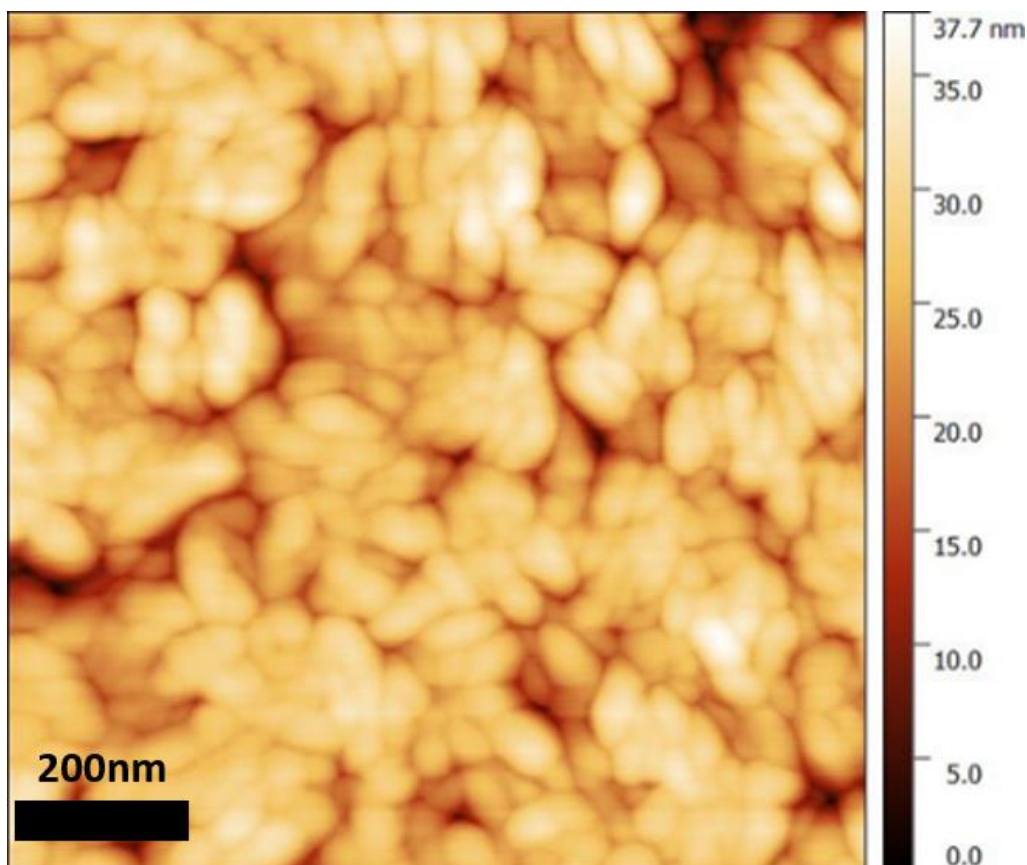


Figure 2. AFM image of TiW substrate.

XPS analysis of the pristine TiW surface showed the presence of carbon. After O₂ plasma oxidation the carbon content decreased from 12% to 10%. Presence of carbon even after O₂ plasma is attributed to surface contamination due to atmospheric amorphous carbonated aerosols, since samples are processed in air.^{23,24} W4f and Ti2p core levels are shown on **Figure 3** and O1s core level on **Figure 4**. ATR-FTIR spectra of control bare TiW (O₂ plasma treated oxidized TiW without organolayer) and oxidized TiW modified with APPA, APDMES and DA organolayers are presented in **Figure 5**.

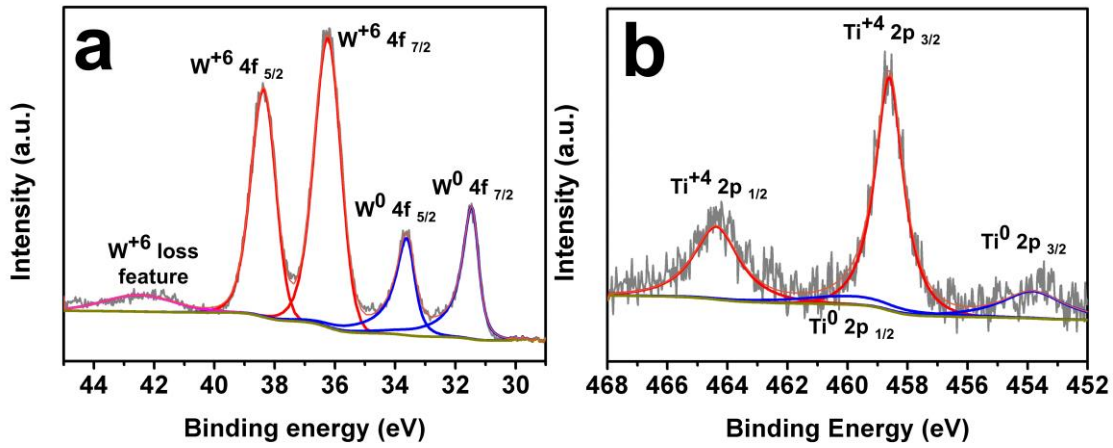


Figure 3. W 4f core level (a) and Ti 2p core level (b) of the control TiW.

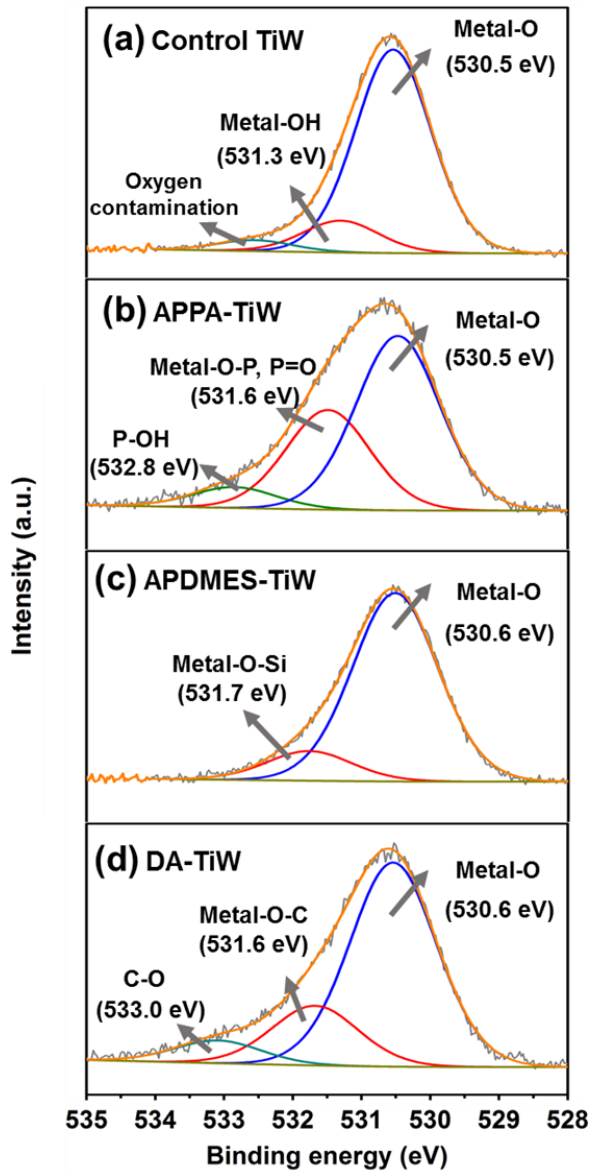


Figure 4. O1s components of (a) control TiW, (b) APPA-TiW, (c) APDMES-TiW and (d) DA-TiW.

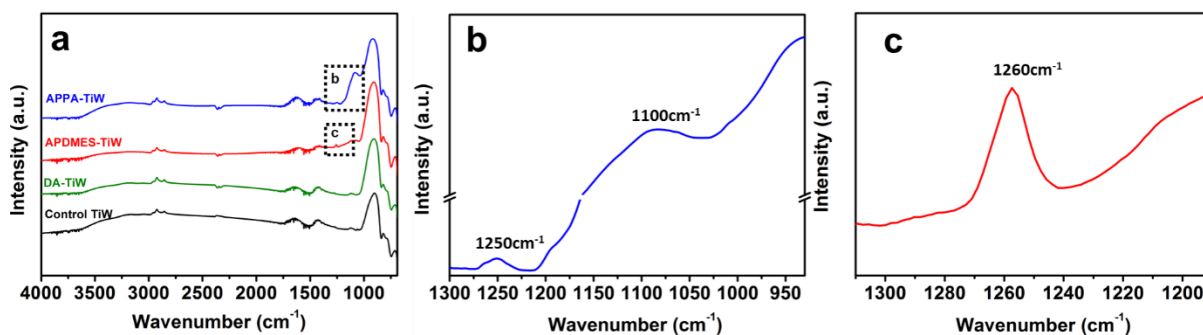


Figure 5. (a) ATR-FTIR spectra of control oxidized TiW (no organolayer) and TiW modified with APPA, APDMES and DA. (b) Enlarged spectrum of the APPA-TiW substrate from 950 cm^{-1} to 1300 cm^{-1} . (c) Enlarged spectrum of the APDMES-TiW substrate from 1300 cm^{-1} to 1200 cm^{-1} .

Atomic percentages of the different elements, obtained from XPS analysis, are reported in **Table 1**, while normalized area of O1s component are reported in Table 2. Survey spectra of plasma-oxidized TiW surface after plasma cleaning are reported on **Figure S1**: neither P, Si nor N is detected. On **Figure 3a**, for plasma oxidized TiW substrate $W4f_{7/2}$ and $W4f_{5/2}$ appear at 31.6 eV and 33.7 eV as expected for metallic W^0 in TiW. This $W4f_{7/2}$ from the substrate at 31.6 eV will be set as the binding energy reference in the following. The presence of well-defined doublets located at 36.1 eV and 38.2 eV along with a broad feature at higher binding energy typical of W^{6+} state in oxides is consistent with an oxidized TiW surface.^{25, 26} In Figure 3b, $Ti2p_{3/2}$ and $Ti2p_{1/2}$ with binding energies of 458.6 eV and 464.4 eV correspond to Ti^{4+} state in oxides while two other peaks observed at 453.7 eV and 459.7 eV correspond to metallic Ti^0 in TiW.^{27, 28} The area ratio of W/Ti corrected by photoionization cross-section is 2.4: the TiW substrate contains more W than Ti. In **Figure 4a**, O1s spectra shows two peaks located at 530.5 eV and 531.3 eV which are identified as contributions from metal oxides (labelled Metal-O) and from metal hydroxides (labelled Metal-OH). A third peak is attributed to oxygen contamination. Contributions in O1s from bonding with W and Ti are too close to be separated,

therefore, TiW will be referred as “metal” (M) in the following.²⁹ As these results indicate that OH groups were present on the surface of the TiW substrate, the surface could be functionalized by organosilane, organophosphonic acid and *ortho*-dihydroxyaryl compounds.

The thickness of the oxidized TiW layer t_{oxide} can be estimated from Figure 3a. The intensity attenuation of W^{04f} by the oxidized TiW layer according to Beer Lambert law is: $A \sim (1 - \exp(-t_{\text{oxide}}/\lambda))/\exp(-t_{\text{oxide}}/\lambda)$, where A is the intensity area ratio $W^{04f}_{7/2} / W^{+64f}_{7/2}$, λ is the mean free path of electrons in the oxide (λ for $W^{04f}_{7/2} \sim 3.8$ nm from the predictive formulae,³⁰ t_{oxide} is the oxide thickness. The surface oxide has a thickness $t_{\text{oxide}} \sim 1$ nm.

The OH surface concentration $(Cs)_{\text{OH}}$ was estimated from XPS O1s core level, according to the method presented by Shircliff:³¹

$$(Cs)_{\text{OH}} \sim \frac{A(\text{metal-OH})_{\text{TiW}}}{A(\text{O1s})_{\text{TiW}}} n_{\text{oxide}} \cdot t_{\text{oxide}} \quad (1)$$

where $A(\text{Metal-OH})_{\text{TiW}}$ is the normalized area (corrected by photoionization cross-section) of the component (Metal-OH) in O1s and $A(\text{O1s})_{\text{TiW}}$ is the total normalized area of O1s for bare oxidized TiW surface. The normalized areas for O1s components are reported in **Table 2**. The molecular concentration n_{oxide} of oxidized TiW was calculated by approximating oxidized TiW as a composition of TiO_2 and WO_3 . Density d ($\text{g} \cdot \text{nm}^{-3}$) and molar mass ($\text{mol} \cdot \text{g}^{-1}$) of TiO_2 and WO_3 were used to evaluate the molar concentration ($\text{mol} \cdot \text{nm}^{-3}$) of TiW oxide, taking into account the W:Ti ratio of $17.6/7.2 \sim 2.4$ as measured by XPS. This yielded an approximated value of $n_{\text{oxide}} \sim 22$ molecules. nm^{-3} . t_{oxide} is the above evaluated oxidized TiW thickness (~ 1 nm). $A(\text{metal-OH})$ and $A(\text{O1s})$ are given in **Table 2**. The calculated $(Cs)_{\text{OH}}$ value using this method is approximately $3 \text{ OH} \cdot \text{nm}^{-2}$. This is close to the value reported for hydroxyl groups in the case of TiO_2 substrates.³² XPS measurements are expected to overestimate surface concentrations because of surface roughness.

APDMES, APPA, and DA binding mode on oxidized TiW surface

O1s core levels are shown in **Figure 4**. N1s, P2p, and Si2p core levels are shown on **Figure 6**. XPS survey spectra of APDMES-TiW, APPA-TiW and DA-TiW are shown on **Figure S1**. APPA-TiW shows distinct N1s (401.0 eV), P2s (190.3 eV), and P2p (133.2 eV) peaks, APDMES-TiW shows distinct N1s (401.0 eV), Si2s (153.3 eV) and Si2p (101.3 eV) peaks and DA-TiW shows distinct N1s (401.0 eV) in addition to W and Ti core levels. The existence of N1s, P2p and/or Si2p confirms the success of the grafting. After surface functionalization, Ti, W and O atomic percentages decrease as expected for core levels from a substrate covered by an overlayer. The percentage ratio W4f/Ti2p remains stable. As the percentage ratios O1s/Ti2p and C1s/Ti2p increase, part of the oxygen and/or carbon is thought to originate from the organic grafting.

On all functionalized surfaces, a similar N atomic percentage was observed (3-4%). 3.3% of P and 3.6% of Si were measured on APPA-TiW and APDMES-TiW, respectively. The N/P and N/Si ratios (nearly 1) are in good agreement with the chemical structures of the two molecules.

	C1s	O1s	Ti2p	W4f	N1s	P2p	Si2p
Control	9.6 ± 0.8	65.6 ± 1.1	7.2 ± 0.8	17.6 ± 0.8	-	-	-
APPA-TiW	33.3 ± 1.0	53.2 ± 0.9	2.0 ± 0.6	4.6 ± 0.6	3.6 ± 0.3	3.3 ± 0.3	-
APDMES-TiW	29.8 ± 0.9	55.8 ± 0.5	2.4 ± 0.7	4.8 ± 0.6	3.5 ± 0.4	-	3.6 ± 0.5
DA-TiW	38.7 ± 0.5	49.9 ± 1.0	2.7 ± 0.5	5.3 ± 0.6	3.3 ± 0.3	-	-

Table 1. XPS atomic percentages of control and of three organolayers functionalized O₂ plasma cleaned TiW.

	Metal-O	Metal-OH	Metal-O-P & P=O	P-OH	Metal-O-Si	Metal-O-C	C-O
Control	2434	390	-	-	-	-	-
APPA-TiW	1161		663	139	-	-	-
APDMES-TiW	2542	-	-	-	400	-	-
DA-TiW	1944	-	-	-	-	568	216

Table 2. Normalized area of O1s components for the oxidized TiW and the three organolayers on oxidized TiW.

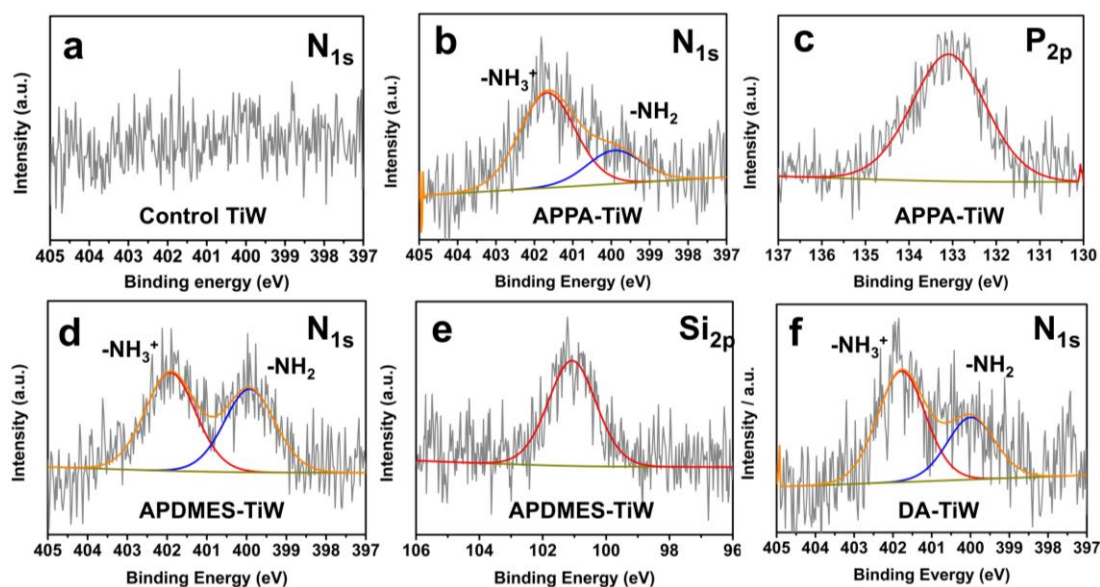


Figure 6. (a) N_{1s} core level of control TiW. (b) N_{1s} core level and (c) P_{2p} core level of APPA-TiW, (d) N_{1s} core level and (e) Si_{2p} core level of APDMES-TiW, (f) N_{1s} core level of DA-TiW.

Two contributions are present in the high-resolution N_{1s} core level for APPA-TiW, APDMES-TiW, and DA-TiW, which were associated with a free amine -NH₂ group at 399.8 eV and protonated amine -NH₃⁺ group at 401.7 eV, respectively.^{33,34} High-resolution XPS spectra of the P_{2p} confirms phosphorus functionalization. In our work, after grafting on oxidized TiW,

the P2p is seen at 133.2 eV. The P2p core level is expected at 134.1 eV for the non-deprotonated $-\text{PO}_3\text{H}_2$ acid.^{35,36} It is generally accepted that a shift of P2p toward lower binding energy is associated with the deprotonation of the terminal P-OH.³⁷⁻³⁹ Therefore, the present shift to a lower binding energy seems to reveal a full or partial deprotonation of terminal P-OH groups. The P2p shift of 0.9 eV observed here is in agreement with typical shifts reported for phosphonic acids on metal oxide surfaces.^{35,38} From high-resolution Si2p spectra of APDMES-TiW (**Figure 6e**), a Si2p peak was observed at 101.3 eV and assigned to the silicon $\text{Si}(\text{O})_1$ of APDMES onto the oxidized TiW surface.^{40,41} The covalent attachment of a monofunctional organosilane is the result of a single condensation reaction to metal oxide surface. As the silicon atom of the organosilane is linked with a single oxygen atom, its binding energy must be lower than the one measured on silica or multifunctional silanes.³³ The presence of APDMES is confirmed by the intense ATR-FTIR peak around 1260 cm^{-1} (**Figure 5c**), attributed to the $\text{Si}-\text{CH}_3$ bend.⁴² However the NH_2 scissor vibration for APDMES at 1570 cm^{-1} was not observed in our case. It has been reported that the bonding between an amine and a surface bound hydroxyl is much weaker than any other bonding and rinsing with the solvent easily removes physisorbed molecules.^{18,43}

The high-resolution O1s spectra of different organolayers coated on metal oxide surface have been reported on **Figure 4**. The binding energy of the components depends on the type of organolayers grafted on the surface. **Figure 4a** shows O1s core level of the initial oxidized TiW substrate. The Full width half maximum (FWHM) of the oxygen contribution was set to 1.4 eV. O1s is resolved into three contributions. The peak at 530.5 eV is assigned to lattice oxygen from the metal oxides. The peak at 531.3 eV was assigned to the chemisorbed oxygen caused by surface hydroxyl. The weak peak at 532.0 eV represents the surface oxygen contamination.⁴⁴

For APPA-TiW, the **ATR-FTIR spectrum** absorbance peak around 1100 cm^{-1} in **Figure 5** can be assigned to a convolution of symmetric and asymmetric stretching bands of the phosphonate groups (PO_3^{2-}). The presence of this stretching vibration indicates the deprotonation of the phosphonic acid group.^{45,46} A broad band at 1250 cm^{-1} was assigned to the P=O stretching mode from the free P=O groups of molecules. It also indicated that APPA bonding to TiW surface occurred via deprotonated OH groups while the P=O groups do not directly bond to the surface. This may correspond to modes (a1) monodentate APPA; (a2, a3) bridging bidentate APPA and (a4) chelating bidentate in **Scheme 1**. Other studies report that the bonding mode of phosphonate to the metal oxide surfaces occurs via a bidentate bonding (**Figure 5b**).^{47,48} APPA-TiW XPS analysis in **Figure 4b** provided further information: the peak at 531.6 eV was assigned to P-O-metal and P=O. The contribution located at 532.8 eV was ascribed to P-OH species. The ratio of P=O oxygen contribution over that of P-OH should be 0.5 for pure APPA layer. By assuming that the sum of normalized area of the components (Metal-O-P, P=O) and (P-OH) in O1s is equal to 1.

The normalized area of the component (P-OH) is 0.17 (measurements reported on Table 2). Since one third of the bond between P and O of each APPA should be a P=O in every mode in Scheme 1, the normalized area of the component (P=O) alone should be around 0.33. From these values, the normalized area of the component (Metal-O-P) was estimated around 0.5. If all bound APPA were only monodentate (binding mode a1), one third of the (P,O) bonds would correspond to (P-OH). However, XPS measurements show that P-OH accounts for only 17% of (P,O) bonds. Therefore, approximately half of APPA molecules are monodentate (one of the two P-OH is free, binding mode a1 in **scheme 1**), while the other half are bidentate (two Metal-O-P bonds per APPA molecule: binding modes a2, a3 or a4 in **scheme1**).

XPS O1s core level was resolved into only two components (**Figure 4c**). Besides the Metal-O bonding oxygen, the peak at 531.7 eV was attributed to oxygen atoms in surface hydroxyl or Si-O-metal species, which is in agreement with the other studies.^{49,50}

For DA-TiW, XPS peak at 531.6 eV in **Figure 4d** was assigned to Metal-O-C. The peak located at higher binding energy (533.0eV) was ascribed to oxygen bonded to aromatic carbon.^{22,51}

Although bidentate mode of attachment was referred to as the stable structure, we think that monodentate and bidentate complexes co-exist on the surface because of the peak at 533.0 eV which means that only one of catechol -OH moiety is involved in the bonding.⁵² By assuming that the sum of normalized area of the components (Metal-O-C) and (C-O) in O1s is equal to 1, the normalized area of the component (C-O) is 0.27 (measurements reported in **Table 2**). From these values, the normalized area of the component (Metal-O-C) is estimated around 0.73. Approximately half of DA molecules would be monodentate (one of the two C-O is free), while the other half are bidentate (two Metal-O-C bonds per molecule).

XPS Metal-O-P and Metal-O-Si components as a measurement of APPA & APDMES surface coverages.

XPS analysis was used for evaluating organolayer surface concentrations (C_s) for APPA and APDMES. These (C_s) values could be compared with theoretical values of the maximum surface concentration obtained for a compact monolayer ($C_{s_{max}}$).

(C_s) surface concentration measured from XPS: we define herein experimental surface concentration as the number of organic molecules per area unit. (C_s) values were evaluated using two calculation methods: (a) contribution of N1s for each type organolayer, using nitrogen as a reporter for our organic molecules; (b) respective contributions of Si2p and P2p for APDMES-TiW and for APPA-TiW. The detected carbon contamination prevented us to use this second approach with C1s for DA-TiW.

Calculations and XPS data are presented in equations 2 to 6 and **Table 3** below:

$$(Cs)_{APDMES} \sim \frac{A(N1s)_{APDMES}}{A(Metal-O)_{APDMES}} n_{oxide} t_{oxide} \quad (2)$$

$$(Cs)_{APDMES} \sim \frac{A(Si2p)_{APDMES}}{A(Metal-O)_{APDMES}} n_{oxide} t_{oxide} \quad (3)$$

$$(Cs)_{APPA} = \frac{A(N1s)_{APPA}}{A(Metal-O)_{APPA}} n_{oxide} t_{oxide} \quad (4)$$

$$(Cs)_{APPA} = \frac{A(P2p)_{APPA}}{A(Metal-O)_{APPA}} n_{oxide} t_{oxide} \quad (5)$$

$$(Cs)_{DA} = \frac{A(N1s)_{DA}}{A(Metal-O)_{DA}} n_{oxide} t_{oxide} \quad (6)$$

Organolayer	N1s	P2p	Si2p
APPA-TiW	121.5	132.5	-
APDMES-TiW	220.9	-	199.1
DA-TiW	145.9	-	-

Table 3: Normalized area of N1s, P2p and Si2p for the three organolayers on oxidized TiW
Results are presented in **Table 4**.

Organolayer on oxidized TiW	(Cs) surface concentration (molecules.nm ⁻²)	(C _{Smax}) theoretical maximum surface concentration (molecules.nm ⁻²)
Bare oxidized TiW	Using O1s: ~3 OH.nm ⁻²	-
APPA	using N1s: ~1.9 ± 0.5 APPA.nm ⁻² using P2p: ~2.2 ± 0.5 APPA.nm ⁻²	4.7 ± 0.9 APPA.nm ⁻²
APDMES	using N1s: 2.3 ± 0.5 APDMES.nm ⁻² using Si2p: ~1.8 ± 0.5 APDMES.nm ⁻²	2.7 ± 0.9 APDMES.nm ⁻²
DA	using N1s: ~1.6 ± 0.5 DA.nm ⁻² using C1s: not determined	4.4 ± 0.9 DA.nm ⁻²

Table 4. evaluation of surface concentrations. (Cs) surface concentration of –OH moieties on bare oxidized TiW, and surface concentration of bound molecules estimated from XPS measurements; for each organolayer, calculations were performed using XPS data for N1s. Additionally XPS data of P2p and Si2p were also used for APPA and Si, respectively. XPS data of C1s could not be used for DA because of atmospheric carbon contamination. $(Cs)_{max}$ theoretical maximum surface density calculated for compact organolayer and estimated from theoretical calculations after Shircliff et al.³¹

The calculated values in for N1s, Si2p and P2p seem consistent. ToF-SIMS considerations enabled to confirm XPS results (see below). DA surface concentration could not be determined because of difficult interpretation in spectra related to carbon contamination.

(Cs_{max}) theoretical maximum surface concentration calculated for saturated monolayers: theoretical maximum surface concentration calculated for saturated monolayers of APDMES, APPA and DA were calculated using the method presented by Shircliff et al.³¹ given in equation (7):

$$(Cs_{max}) = \frac{t.d.a.N}{MW} \quad (7)$$

Where t is the monolayer thickness (0.6 +/- 0.2 nm), d is the density of APDMES, APPA and DA (0.857 g/cm³; 1.378 g/cm³; 1.47 g/cm³ respectively) , a is a conversion factor (10⁻²¹ cm³/nm³), N is Avogadro's number, and MW is the molecular weight of APDMES, APPA and DA without their hydrolysable moieties (116 g/mol, 105 g/mol and 122 g/mol, respectively) . The calculations result in 2.7 +/- 0.9 APDMES molecules.nm⁻², 4.7 +/- 0.9 APPA molecules.nm⁻², and 4.4 +/- 0.9 DA molecules.nm⁻². These values are higher than the experimental surface concentration (Cs) calculated from our XPS measurements. It therefore suggests that our three organolayers are not compact.

ToF-SIMS analysis was also used to characterize the three organolayers functionalized TiW with the aim of confirming XPS results thanks to the molecular information brought by the mass detection. Due to contamination issues -to which ToF-SIMS is by far more sensitive than XPS- fresh samples were prepared just prior to ToF-SIMS analysis, in order to limit atmospheric contamination as much as possible.

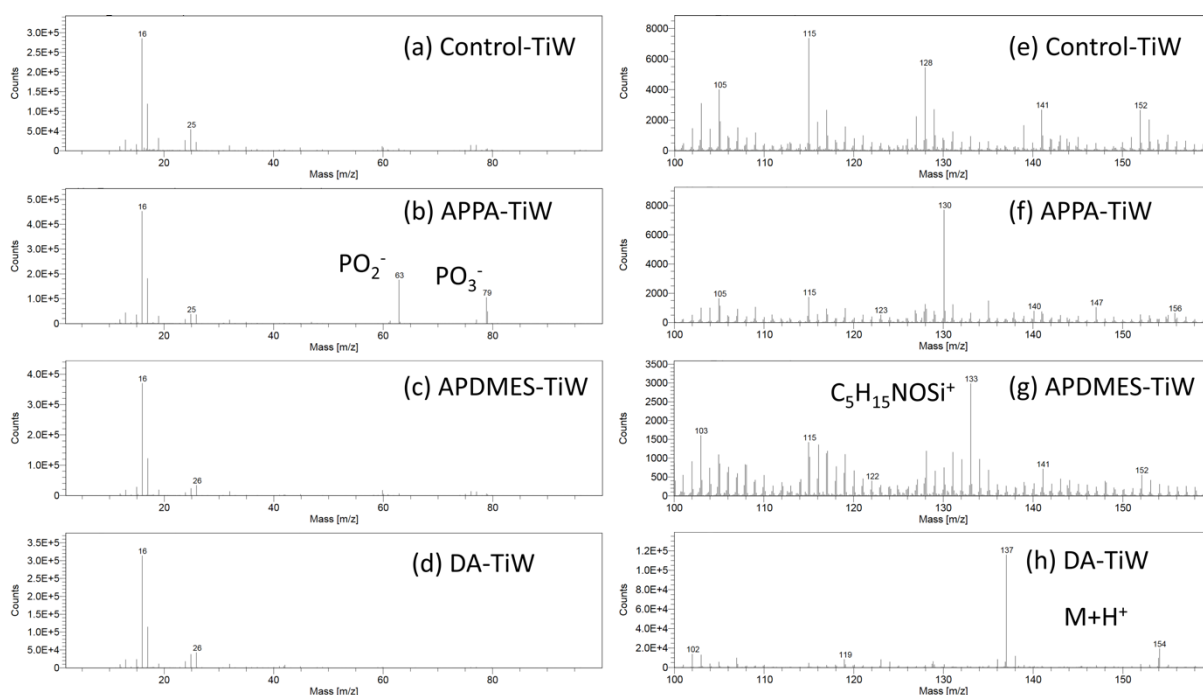


Figure 7. Negative mode (a-d) and positive mode (e-h) ToF-SIMS spectra of control TiW, APPA-TiW, APDMES-TiW and DA-TiW in the ranges of $m/z = 0-100$ (negative mode) and $m/z= 100-160$ (positive mode).

Negative mode spectra (**Figure 7a-d**) firstly indicates an increase in relative intensity of the nitrogen containing ions for APPA, APDMES and DA modified TiW compared to control bare TiW treated with O_2 plasma. For example, on the bare TiW, the main contribution at $m/z = 26$ is assigned to $C_2H_2^-$ at $m/z=26.02$ ion, while on the organolayers the main contribution is the CN^- peak detected at $m/z=26.00$. A strong relative intensity for the phosphonic acid group characteristic peaks (PO_2^- m/z 62.97 and PO_3^- m/z 78.97) is specifically detected for the APPA-TiW.⁶¹ An increase in the relative intensity of the peak at m/z 30 (CH_4N^+) is noticeable after surface formation of the organolayers. Contamination is also detected such as aromatic peaks

at m/z 77.04, 91.05, 105.07, 115.05 etc. corresponding to $C_6H_5^+$, $C_7H_7^+$, $C_8H_9^+$, $C_9H_7^+$, respectively (**Figure 7e-h**). Nitrogen-based contamination has been also detected at the surface of the APPA-TiW sample at m/z 130.15. APDMES and DA molecular information related to the functionalization was more clearly detected in the positive mode. For APDMES-TiW samples, peaks were detected at $m/z=116.09$ ($C_5H_{14}NSi^+$) and 133.08 ($C_5H_{15}NOSi^+$). For DA-TiW samples, a peak is detected at $m/z=154.08$ that corresponds to $M+H^+$. A peak was also detected in the negative mode at $m/z=152.06$, corresponding to $M-H^-$ (data not displayed).

In positive mode spectra (**Figure S2**), strong relative intensities of peaks related to Ti such as peaks at m/z 47.95 and m/z 63.94 for Ti^+ and TiO^+ are observed. Similarly, W related peaks (data not displayed) were also observed. ToF-SIMS is sensitive to the top layers (one to a few monolayers) and is thus more sensitive to the top surface than XPS for which the information depth corresponds to 3-10 nm. As the TiW substrate is still significantly detected, this indicates that it is not fully covered with the intended surface modification. This is consistent with our discussion about XPS. Considering the results and discussions in parts 3.2 and 3.3, we considered that all initial metal-OH of oxidized TiW were used for binding organolayers. However, the final organolayer surface concentrations indicate the formations of submonolayers. In further work, increasing the initial density of metal-OH moieties may be a way to increase the compactness of implemented organolayers.

Effects of immersion in DI water at 70°C

Lereau *et al.* demonstrated that the half-life of monothiol organolayers on gold was less than 5 minutes in hot water.⁵³ Inspired by this report we choose to compare the stability of the three organolayers by immersion of the modified TiW in 70°C water. XPS atomic percentages were determined as a function of immersion time. The change of different elements concentration is listed in **Table 5**.

	C1s	O1s	Ti2p	W4f	N1s	P2p	Si2p
APPA-TiW	30.6 ± 0.7	57.5 ± 0.6	2.5 ± 0.4	4.5 ± 0.5	2.5 ± 0.2	2.4 ± 0.3	-
APDMES-TiW	22.7 ± 0.6	61.1 ± 0.5	5.0 ± 0.6	10.5 ± 0.7	0.3 ± 0.1	-	0.4 ± 0.1
DA-TiW	29.2 ± 0.8	58.8 ± 0.9	2.8 ± 0.5	7.6 ± 0.4	1.6 ± 0.2	-	-

Table 5: XPS atomic percentages of the APPA-TiW, APDMES-TiW and DA-TiW after 60 minutes immersion in 70°C DI water. To be compared with Table 2.

The ratios of N1s at. % to (Ti2p at. % +W4f at. %) as a function of time are displayed in **Figure 8a**. The N1s at. % / (Ti2p at. % +W4f at. %) ratio of APPA-TiW decreased from 0.55 to 0.38 within the first 15 minutes and then, it remained constant for the next 45 minutes. In a similar fashion (**Figure 8b**), the P2p at. % / (Ti2p at. % +W4f at. %) ratio decreases and reaches a plateau after 15 minutes of immersion time. For DA-TiW, the N1s at. % / (Ti2p at. % +W4f at. %) ratio decreased continuously from 0.42 to 0.19 after 60 minutes of immersion time. Finally, for APDMES, the N1s at. % / (Ti2p at. % +W4f at. %) ratio drops to 0 within 15 minutes. In a similar manner (APDMES-TiW), the Si2p at. % / (Ti2p at. % +W4f at. %) ratio decreases with increased immersion time and Si is not significantly observed after 15-30 minutes of immersion time (**Figure 8c**). On the contrary, the contributions of the substrate increase from 2.5 to 5 % after 60 min immersion for Ti2p at. % and from 5 to 10 % f after 60 min immersion or W4f at. % illustrating the removal of the APDMES organolayers (**Table 4**). Therefore, it is estimated that the APDMES layer is almost fully removed. 50 % of the DA layer and nearly 30% of the APPA layer are depleted after 60 minutes of immersion (**Figure 8d**). Our results suggest that the rate and amount of molecules desorbed for APDMES-TiW is the highest. DA-TiW seems slightly less stable than APPA-TiW.

In some comparative published studies, the stability of different organolayers on metal oxide have been reported.^{44,54-62} The exact state of bonding responsible for the stability of organolayers on metal oxides is still a matter of debate. It has been claimed that Si-O-Ti is more stable than P-O-Ti.^{44,54} However, M. J. Stevens suggested that the stability was rather in fact due to the lateral crosslinking of multifunctional organosilane.⁵⁵ In our case, lateral cross linking was not possible as we have used a monovalent silane. We observed that the APDMES layer was almost completely removed after 15 min of immersion time in 70 °C H₂O suggesting that the Si-O-Ti or Si-O-W bonds are somehow labile and that the stability reported by several authors may rather be due to lateral cross linking. Different phosphonate layers on indium–tin oxide, cobalt chromium alloys and aluminum surfaces were found to be stable and strongly bound.⁵⁶⁻⁶¹ In addition, it has been showed that tungsten oxide surface can react with phosphonate molecules to form the covalently attach tethered by phosphonate linkers. And the P-O bonds (3.5 eV/bond) on tungsten/tungsten oxide seems to be twice as strong as S-Au attachments (1.7 eV/bond).⁶² Here the rate and amount of molecules desorbed for APPA-TiW are lower compared to the other two layers which maybe resulted from the stronger P-O-Ti and P-O-W covalent bonds. For DA layer, we proposed that monodentate and bidentate complexes of catechol co-exist on the surface. In the literature, the bidentate attachment is considered more stable than the monodentate complex.⁴ It may well be that after immersion in 70 °C H₂O, the relatively unstable monodentate complexes may continuously desorb from the surface.⁴⁵

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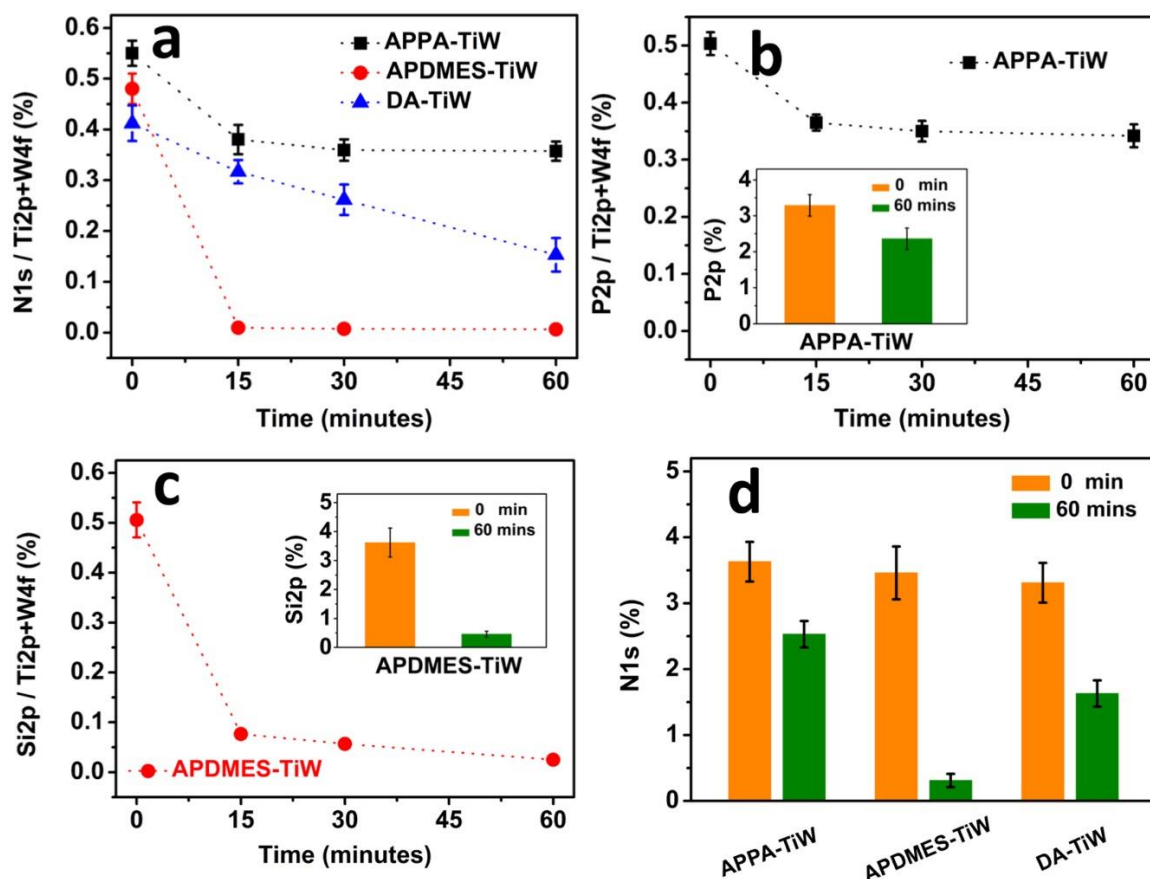


Figure 8. (a) N1s at. % / (Ti2p at. % + W4f at. %) ratio for the APPA- TiW, APDMES-TiW and DA-TiW as a function of immersion time in DI water at 70°C. (b) P2p at. % / (Ti2p at. % + W4f at. %) ratio of APPA-TiW DI H₂O at 70°C as a function of immersion time. The inset shows the P2p concentration change. (c) Si2p at. % / (Ti2p at. % + W4f at. %) ratio of APDMES-TiW in DI H₂O at 70°C as a function of immersion time. The inset shows the Si2p concentration change. (d) N1s atomic percentage (at. %) of APPA-TiW, APDMES-TiW and DA-TiW before and after 60 minutes' immersion in DI H₂O at 70°C.

CONCLUSION

Herein we have studied the grafting of phosphonate, silane and ortho-dihydroxyaryl compounds on oxygen plasma cleaned TiW. The resulting layers were analyzed by XPS, ToF-SIMS and IR. Firstly, XPS, IR and ToF-SIMS spectroscopy seem to sustain the formation of a covalent attachment between APPA and TiW. Similarly, the bonding of the APDMES layer seems to occur through the covalent bonds between the monovalent silane and oxide. Our

results tend to indicate that DA binding on TiW leads to monodentate and bidentate configurations grafting. The stabilities of three organolayers on TiW was also investigated and compared. Based on XPS, the good stability of APPA organolayer may mainly be attributed to stronger P-O-W and P-O-Ti covalent bonds. The stability of DA organolayer on TiW was inferior to the stability of APPA organolayer probably because of the instability of monodentate mode. Extensive desorption of APDMES molecules occurred within 15 min of immersion in 70 °C water due to the lack of lateral cross linking in the layer. As a novel functional metal oxide, quite good stability of phosphonic acid organolayer functionalized TiW has important significance in terms of further functionalization and integrated multi-materials patterned substrate devices^{64, 65}.

This study sets the basis of TiW functionalization for our future work on the development of chemical sensors and biosensors based on industrial nanoelectronic devices. Further work may indeed be performed for grafting biomolecular probes onto TiW. Biomolecules may for instance be immobilized using a cross-linker exhibiting at one end a phosphonate moiety, and at the other end a reactive group such as carboxylic acid⁶⁵. Biomolecules such as proteins, peptide nucleic acids or oligonucleotides bearing a terminal primary amine could then be grafted on such surface, prior to assessing the nanoelectronic sensors.

ASSOCIATED CONTENT

Supporting Information. The Supporting Information is available free of charge on the ACS Publications website at DOI:

XPS survey scans; Positive mode ToF-SIMS spectra of control TiW, APPA-TiW, APDMES-TiW and DA-TiW in the ranges of $m/z= 20-160$; (PDF)

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The manuscript was written through contributions of all authors. All authors have given approval to the final version of the manuscript.

Notes

The authors declare no competing financial interest.

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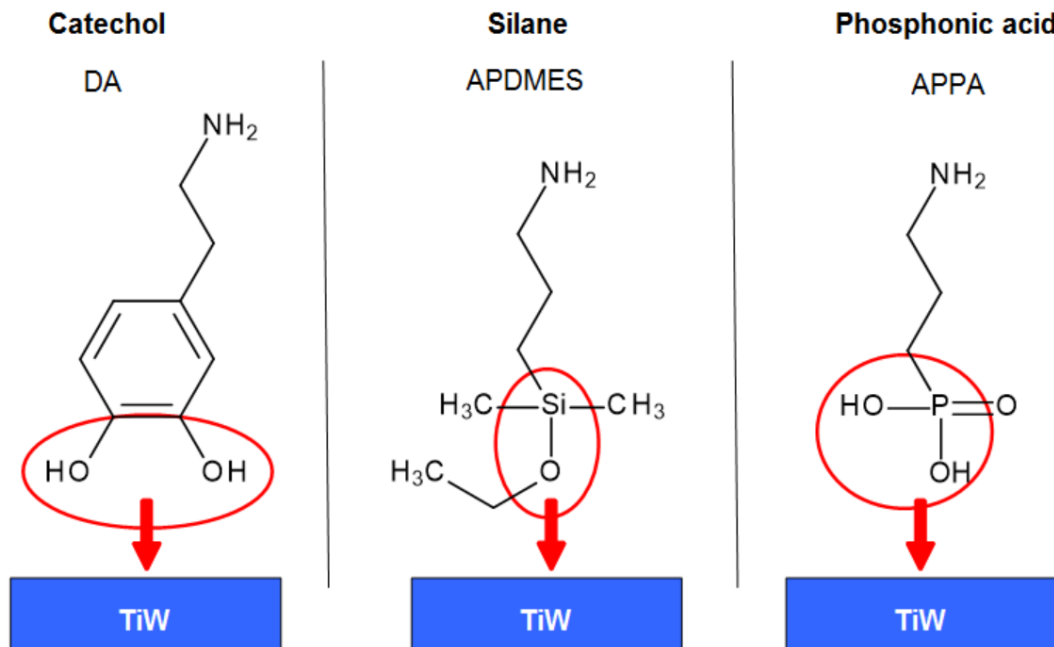
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Supporting information:

Oxidized titanium tungsten surface functionalization by silane, phosphonic acid or ortho-dihydroxyaryl based organolayers

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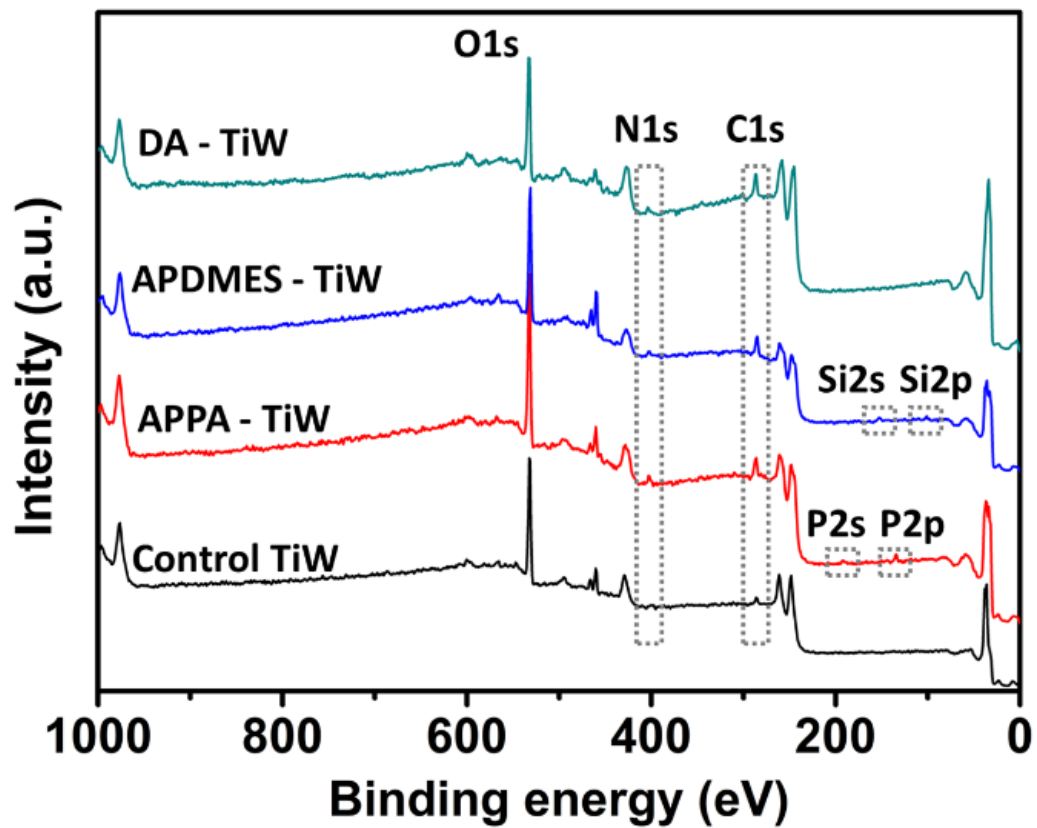


Figure S1. XPS survey scans of control TiW, APPA-TiW, APDMES-TiW and DA-TiW.

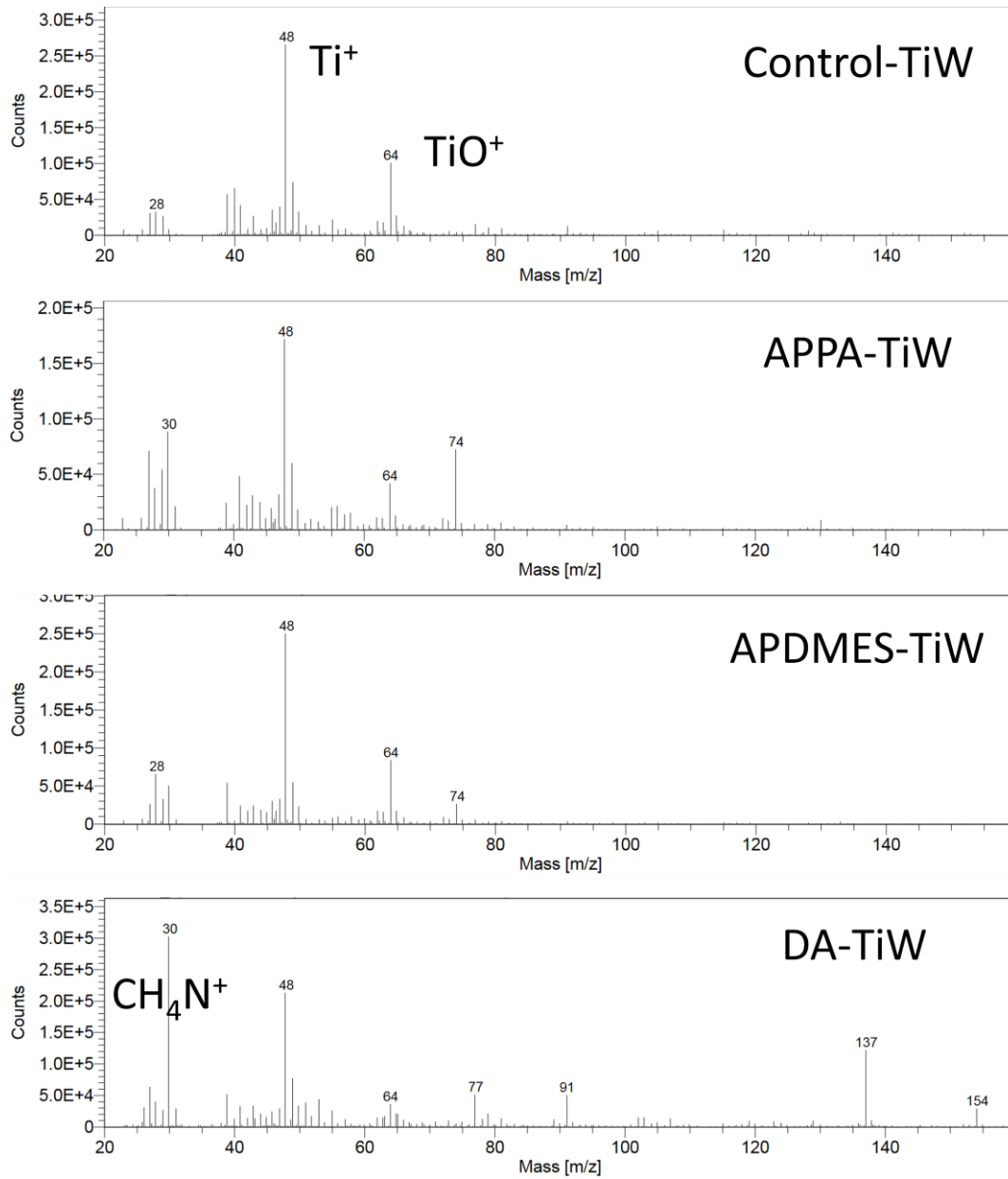


Figure S2: Positive mode ToF-SIMS spectra of control TiW, APPA-TiW, APDMES-TiW and DA-TiW in the ranges of $m/z=20-160$.